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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

OHTAKE, Fumio et al.

Serial No.: 09/749,590

Filed: **December 28, 2000**

For: **SEMICONDUCTOR DEVICE HAVING GATE ELECTRODES WITH POLYMETAL
STRUCTURE OF POLYCRYSTALLINE SILICON FILMS AND METAL FILMS (as
amended)**

Group Art Unit 2814

Examiner: MAI, Anh D.

P.T.O. Confirmation No.: 2831

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AMENDMENT

Commissioner for Patents
Washington, D.C. 20231

October 2, 2002

Sir:

In response to the Office Action dated June 6, 2002, please amend the above-identified application
as follows:

IN THE DRAWINGS:

Submitted herewith is a Request for Approval of Drawing Corrections, along with proposed
drawing corrections to Figures 5, 6, 7, 8, 9 and 11, marked in red ink.

IN THE TITLE:

Amend the title of the invention, in its entirety, to read as follows:

SEMICONDUCTOR DEVICE HAVING ~~GATE~~ ELECTRODES WITH POLYMETAL
STRUCTURE OF POLYCRYSTALLINE SILICON FILMS AND METAL FILMS